

DECLARATION

As a below named inventor, I hereby declare that:

My residence, post office address and citizenship are as stated below next to my name,

I believe I am the original, first and sole inventor (if only one name is listed below) or an original, first and joint inventor (if plural names are listed below) of the subject matter which is claimed and for which a patent is sought on the invention entitled:

Vacuum Processing for Fabrication of Superconducting Thin Films Fabricated by Metal-Organic Processing

the specification of which (I authorize Choate, Hall & Stewart to check one of the following, three choices, and fill in the blanks, if applicable):

_____ is attached hereto

X was filed on July 13, 2002 as Application Serial No. 10/194,561 (I authorize Choate, Hall & Stewart to fill in this information) and amended on _____ (if applicable).

_____ was filed as PCT international application No. _____, on _____ and was amended under PCT Article 19 on _____ (if applicable).

I hereby state that I have reviewed and understood the contents of the above-identified specification, including the claims, as amended by any amendment referred to above.

I acknowledged the duty to disclose information which is material to the examination of this application in accordance with Title 37, Code of Federal Regulations, §1.56.

I hereby claim foreign priority benefits under Title 35, United States Code, §119 of any foreign application(s) for patent or inventor's certificate listed below and have also identified below any foreign application for patent or inventor's certificate having a filing date before that of the application on which priority is claimed:

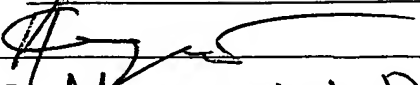
Prior Foreign Application(s):

Priority Claimed

_____ (Number)	_____ (Country)	_____ (Day/Month/Year/Filed)	_____ Yes	_____ No
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_____ (Number)	_____ (Country)	_____ (Day/Month/Year/Filed)	_____ Yes	_____ No
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1) Full name of first inventor: Igor Seleznev

Inventor's signature: 

Date: 07/30/02

Mailing Address: 540 Memorial Dr. Apt 1607 Cambridge, MA

Citizenship: Russia

Residence (if different from mailing address): City: Cambridge State: MA

2) Full name of second inventor: Michael J. Cima

Inventor's signature: _____

Date: _____

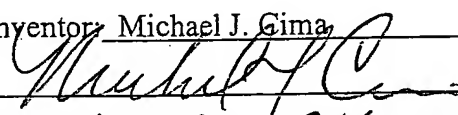
Mailing Address: _____

Citizenship: _____

Residence (if different from mailing address): City: Winchester State: MA

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1) Full name of first inventor: Igor Seleznev
Inventor's signature: _____ Date: _____
Mailing Address: _____
Citizenship: _____
Residence (if different from mailing address): City: Cambridge State: MA

2) Full name of second inventor: Michael J. Gima
Inventor's signature:  Date: 10/3/02
Mailing Address: 77 MASS Ave, Bldg. 12-011, MIT, Cambridge, MA 02139
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